Docket No. 0887-4150US1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Andreas H. Hielschler and Alexander Klose

Group Art Unit: 3737

Serial No.:

09/767,230

Examiner:

Jung C. William

Filed:

January 22, 2001

For:

IMAGING OF A SCATTERING MEDIUM USING THE EQUATION OF

RADIATIVE TRANSFER

INTERVIEW REQUEST TRANSMITTAL

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Applicants have made several attempts to schedule an interview by phone with the Primary and Supervisory Examiner but have not received any response to date. Accordingly, Applicants transmit herewith a written request for an Examiner interview in the above-identified application and respectfully request an Examiner interview to help the Examiner better understand the technology of the invention and the cited prior art.

Respectfully submitted, MORGAN & FINNEGAN, L.L.P.

Dated: April 21, 2006

By:

Registration No. 41,190

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Applicant Initiated Interview Request Form
Application No.: 09/767,230 First Named Applicant: Andreas Hielscher Examiner: William Jung Art Unit: 3737 Status of Application: Pending
Tentative Participants: (1) Tod M. Melgar (3) Alexander Klose (4) Andreas Hielscher (4)
Proposed Date of Interview: May 2, 2006 Type of Interview Requested: (1) Telephonic (2) Personal (3) Video Conference
Exhibit To Be Shown or Demonstrated: Yes No
If yes, provide brief description: PowerPoint slides to assist in explaining the technology
Issues To Be Discussed
Issues(Rej., Obj. etc) Claims/Fig. #s Prior Art Discussed Agreed Not Agreed
Brief Description of Arguments to be Presented: <u>Tutorial on the technology of the invention and prior art and the differences therebetween</u>
An interview was conducted on the above-identified application on
NOTE: This form should be completed by applicant and submitted to the examiner in advance of the interview (see MPEP § 713.01). This application will not be delayed from issue because of applicant's failure to submit a written record of this interview. Therefore, applicant is advised to file a statement of the substance of this interview (37 CFR 1.133(b)) as soon as possible.
(Applicant/Applicant's Representative Signature) (Examiner/SPE Signature)

This collection of information is required by 37 CFR 1.133. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 21 minutes to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any commentson the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patentand Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THISADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.